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**PATENT APPLICATION**

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Attn: OIPE

Akinori KOUKITSU et al.

Group Art Unit: 1722

Application No.: 10/509,177

Docket No.: 121213

Filed: September 27, 2004

For: VAPOR PHASE GROWTH METHOD FOR A1-CONTAINING III-V GROUP  
COMPOUND SEMICONDUCTOR, AND METHOD AND DEVICE FOR  
PRODUCING A1-CONTAINING III-V GROUP COMPOUND SEMICONDUCTOR

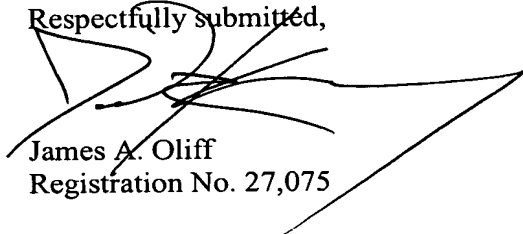
**REQUEST FOR CORRECTION OF PALM RECORDS**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

Attached is a photocopy of the original filing receipt on which errors have been corrected in red. These errors are being brought to the attention of the Patent and Trademark Office so that it may correct its records. A Supplemental Application Data Sheet is attached.

Respectfully submitted,

  
James A. Oliff  
Registration No. 27,075

David R. Kemeny  
Registration No. 57,241

JAO:DRK/dpw

Date: December 29, 2006

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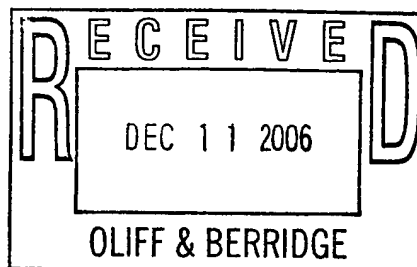


## UNITED STATES PATENT AND TRADEMARK OFFICE

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| APPL NO.   | FILING OR 371<br>(c) DATE | ART UNIT | FIL FEE REC'D | ATTY. DOCKET NO | DRAWINGS | TOT CLMS | IND CLMS |
|------------|---------------------------|----------|---------------|-----------------|----------|----------|----------|
| 10/509,177 | 09/27/2004                | 1722     | 1092          | 121213          | 5        | 17       | 5        |

25944  
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CONFIRMATION NO. 5228

CORRECTED FILING RECEIPT



\*OC000000021524525\*

Date Mailed: 12/07/2006

Receipt is acknowledged of this regular Patent Application. It will be considered in its order and you will be notified as to the results of the examination. Be sure to provide the U.S. APPLICATION NUMBER, FILING DATE, NAME OF APPLICANT, and TITLE OF INVENTION when inquiring about this application. Fees transmitted by check or draft are subject to collection. Please verify the accuracy of the data presented on this receipt. **If an error is noted on this Filing Receipt, please mail to the Commissioner for Patents P.O. Box 1450 Alexandria Va 22313-1450. Please provide a copy of this Filing Receipt with the changes noted thereon. If you received a "Notice to File Missing Parts" for this application, please submit any corrections to this Filing Receipt with your reply to the Notice. When the USPTO processes the reply to the Notice, the USPTO will generate another Filing Receipt incorporating the requested corrections (if appropriate).**

**Applicant(s)**

Akinori Koukitsu, Koganei-shi, JAPAN;  
Yoshinao Kumagai, Koganei-shi, JAPAN;  
Tomohiro Marui, Koganei-shi, JAPAN;

**Assignment For Published Patent Application**

TOKYO UNIVERSITY AGRICULTURE AND TECHNOLOGY TLO CO., LTD., Koganei-shi, JAPAN

LTD.,

**Power of Attorney:** The patent practitioners associated with Customer Number 25944.

**Domestic Priority data as claimed by applicant**

This application is a 371 of PCT/JP03/04408 04/07/2003

**Foreign Applications**

JAPAN 2002-106102 04/09/2002

**If Required, Foreign Filing License Granted:** 09/22/2006

The country code and number of your priority application, to be used for filing abroad under the Paris Convention, is **US10/509,177**

**Projected Publication Date:** Not Applicable

**Non-Publication Request:** No

**Early Publication Request:** No

**Title**

Vapor phase growth method for <sup>A1-</sup>containing III-V group compound semiconductor, and method and device for producing <sup>A1-</sup>containing III-V group compound semiconductor

**Preliminary Class**

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**OLIFF & BERRIDGE, PLC**

ATTORNEYS AT LAW

**Supplemental Application Data Sheet**

**Application Information**

|                            |  |
|----------------------------|--|
| Application Type::         | National Phase   |
| Subject Matter::           | Utility  |
| CD-ROM or CD-R:            | None   |
| Title::                    | VAPOR PHASE GROWTH METHOD FOR Al <sub>A1</sub> -CONTAINING III-V GROUP COMPOUND SEMICONDUCTOR, AND METHOD AND DEVICE FOR PRODUCING Al <sub>A1</sub> -CONTAINING III-V GROUP COMPOUND SEMICONDUCTOR |
| Attorney Docket Number::   | 121213   |
| Suggested Drawing Figure:: |  |
| Total Drawing Sheets::     | 5  |
| Small Entity::             | No   |

**Applicant Information**

|                               |               |
|-------------------------------|---------------|
| Applicant Authority type::    | Inventor      |
| Primary Citizenship Country:: | Japan         |
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| Family Name::                 | KOUKITSU      |
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| Country of Residence::        | JAPAN         |

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|                               |               |
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|                               |               |
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| Status::                      | Full Capacity |
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| Family Name::                 | MARUI         |
| City of Residence::           | Koganei-shi   |
| Country of Residence::        | JAPAN         |

### Correspondence Information

Correspondence Customer Number:: 25944

|   |                      |   |                      |
|---|----------------------|---|----------------------|
| <b>Domestic Priority Information</b>    |                      |   |                      |
|   |                      |   |                      |
| Application::                           | Continuity Type::    | Parent Application::  | Parent Filing Date:: |
|   |                      |   |                      |
| This Application is a                   | National Stage of    | PCT/JP03/04408  | 4/7/2003             |
|   |                      |   |                      |
| <b>Foreign Priority Information</b>     |                      |   |                      |
|   |                      |   |                      |
| Country::                               | Application Number:: | Filing Date::   | Priority Claimed::   |
|   |                      |   |                      |
| JAPAN                                   | 2002-106102          | 4/9/2002  | Yes                  |
|   |                      |   |                      |
| <b>Assignee Information</b>             |                      |   |                      |
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| State or Province of mailing address::  |                      | Tokyo   |                      |
| Country of mailing address::            |                      | JAPAN   |                      |
| Postal or Zip Code of mailing address:: |                      | 184-8588  |                      |
|   |                      |   |                      |